

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **MAIL STOP: RCE**
Akihisa HONGO et al. : Docket No. 2001_0133A
Serial No. 09/762,582 : Group Art Unit 1753
Filed April 12, 2001 : Examiner Brian Mutschler
SUBSTRATE PLATING : **Confirmation No. 5731**
METHOD AND APPARATUS

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
October 27, 2004.

The fee of \$1,020.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion
which

() is enclosed.

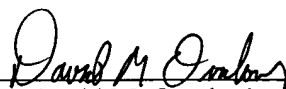
() has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

04/15/2005 MBEYENE1 00000026 09762582
02 FC:1253 1020.00 OP

By


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April 14, 2005